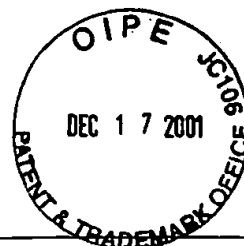


LIST OF PUBLICATIONS FOR  
APPLICANT'S INFORMATION  
DISCLOSURE STATEMENT

Applicant(s): S. Ma et al.  
 Docket No.: YOR920010682US1  
 Serial No.: 09/929,883  
 Filing Date: August 15, 2001  
 Group: 2621



## U.S. PATENT DOCUMENTS

EXAMINER					FILING DATE
INITIAL	DOCUMENT NO.	DATE	NAME	CLASS/SUBCLASS	IF APPROPRIATE
<u>ml</u>	09/739,432	12/18/00	J.L. Hellerstein et al., "Systems and Methods for Discovering Partially Periodic Event Patterns".		
<u>ml</u>	09/918,253	7/30/01	S. Ma et al., "Systems and Methods for Discovering Mutual Dependence Patterns".		

## FOREIGN PATENT DOCUMENTS

EXAMINER					TRANSLATION	
INITIAL	DOCUMENT NO.	DATE	COUNTRY	CLASS/SUBCLASS	YES	NO

## OTHER DOCUMENTS

EXAMINER		REF NO.	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.
INITIAL			
<u>ml</u>		1.	R. Agrawal et al., "Mining Association Rules Between Sets of Items in Large Databases," Proc. of VLDB, pp. 207-216, 1993.
<u>ml</u>		2.	B. Liu et al., "Mining Association Rules with Multiple Minimum Supports," Proceedings of the ACM SIGKDD International Conference on Knowledge Discovery and Data Mining, 1999.
<u>ml</u>		3.	S. Brin et al., "Beyond Market Baskets: Generalizing Association Rules to Correlations," Data Mining and Knowledge Discovery, pp. 39-68, 1998.
<u>ml</u>		4.	E. Cohen et al., "Finding Interesting Associations without Support Pruning," ICDE, pp. 489-499, 2000.
<u>ml</u>		5.	J. Yang et al., "Informiner: Mining Surprising Periodic Patterns," Int'l Conf. on Knowledge Discovery and Data Mining, 2001.
<u>ml</u>		6.	R. Srikant et al., "Mining sequential patterns: Generalizations and performance improvements," Proc. of the Fifth Int'l Conference on Extending Database Technology (EDBT), Avignon, France, 1996.
<u>ml</u>		7.	H. Mannila et al., "Discovery of frequent episodes in event sequences," Data Mining and Knowledge Discovery, 1(3), 1997.

RECEIVED  
 FEB 06 2002  
 Technology Center 2100

RECEIVED  
 DEC 21 2001  
 Technology Center 2600

W. Mandale  
 Examiner

2/23/04  
 Date Considered

**Examiner:** Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.